



Attorney's Docket No.: 07977-046002 / US 3041/3050/3059/3063D1

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shunpei Yamazaki, et al. Art Unit : 1765
Serial No.: 09/304,523 Examiner : Robert Kunemund
Filed : May 4, 1999 Confirmation No. : 9801
Title : METHOD AND APPARATUS FOR PRODUCING SEMICONDUCTOR DEVICE

Commissioner for Patents
Washington, D.C. 20231

RESPONSE

In response to the action mailed November 27, 2002, please consider the following remarks.

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CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

February 27, 2003

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